

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box PATENT APPLICATION
TO THE COMMISSIONER FOR PATENTS
Washington, D.C. 20231

Transmitted herewith for filing is the patent application of:

Inventors: Noriyuki Hirayanagi, Hajime Yamamoto and Tomoharu Fujiwara

For: WAFER CHUCKS ALLOWING CONTROLLED REDUCTION OF
SUBSTRATE HEATING AND RAPID SUBSTRATE EXCHANGE

Enclosed are:

- ☒ 26 pages of specification, 12 pages of claims, an abstract and a Combined Declaration and Power of Attorney.
- ☒ 6 sheets of informal drawings.
- ☒ An assignment of the invention to Nikon Corporation, a Recordation Form Cover Sheet, and a check in the amount of \$40.00 for the recordal fee.
- ☒ A certified copy of each of Japanese patent applications nos. 11-373333, 11-373162, and 2000-004211.

For	FILING FEE				Rate	Basic Fee
	Claims Filed	Number Free		Number Extra		
Total Claims	46	20	=	26	\$18.00	\$468.00
Independent Claims	11	3	=	8	\$80.00	\$640.00
Multiple Dependent Claim Fee					\$270.00	
TOTAL FILING FEE						\$1,818.00

- ☒ A check in the amount of \$1,818.00 to cover the filing fee is enclosed.
- ☒ The Director is hereby authorized to charge any additional fees which may be required in connection with the filing of this application and recording any assignment filed herewith, or credit over-payment, to Account No. 02-4550. A copy of this sheet is enclosed.

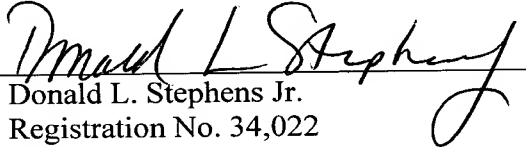
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PATENT
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☒ Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

KLARQUIST SPARKMAN CAMPBELL
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Date: December 27, 2000

By 
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cc: Docketing